경기도 성남시 중원구 상대원동 513-15 선텍시티 I 507 호 (우:462-725)

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1. 2011 년 교육 계획

분기	차수	일시	내용	비고
1/4	24 차	2011.01.21.	MultiPrep System Users Meeting Cross-Section/ TEM Wedge Sample Preparation	
	5 차	2011.03.18	Basic Course: Microstructures Sample preparation for Electronic Materials	
2/4	25 차	2011.04.08	MultiPrep System Users Meeting SIMS SAMPLE PREPARATION	
	6 차	2011.04.15	Basic Course: Microstructures Sample preparation for Metallurgy	
	26 차	2011.05.13	MultiPrep System Users Meeting Cross-Section/ TEM Wedge Sample Preparation	
	2 회	2011.05~06.	EBSD SAMPLE Preparation	2 개월 전 날짜 확정
	27 차	2011.06.24	MultiPrep System Users Meeting Parallel Thinning for Die & Package Analysis	
3/4	7 차	2011.07.15	Basic Course: Microstructures Sample preparation for Electronic Materials	
	28 차	2011.08.19	MultiPrep System Users Meeting Cross-Section/ TEM Wedge Sample Preparation	
	29 차	2011.09.2	MultiPrep System Users Meeting SIMS SAMPLE PREPARATION	
4/4	8 차	2011.10.28	Basic Course: Microstructures Sample preparation for Metallurgy	
	30 차	2011.12.2	MultiPrep System Users Meeting Cross-Section/ TEM Wedge Sample Preparation	
	31 차	2011.12.16	MultiPrep System Users Meeting Parallel Thinning for Die & Package Analysis	

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교육상세내역

MultiPrep System

- 교육대상: MultiPrep System
- 교육참가비용: 10 만원/1 인 (단, 장비보유고객 1 인/1 회 무상)
- 교육참가인원: 선착순 6 명
- 강사: 서임춘/김광섭 실습지원: 신은경

1. Cross-Section/TEM Wedge Sample Preparation

10:00AM~10:50AM	MultiPrep system application
11:00AM~11:50AM	Equipment Calibration 교육 및 실습
12:00AM~01:00PM	점심식사
01:15PM~02:40PM	Sample제작1(Cross-section)
03:00PM~06:00PM	Sample제작2(Wedge Cross-section)

2. Parallel Thinning for Microelectronic device / SIMS sample preparation

10:00AM~10:50AM	MultiPrep system application
11:00AM~11:50AM	Equipment Calibration 교육 및 실습
12:00AM~01:00PM	점심식사
01:00PM~02:10PM	Sample제작1(Parallel Thinning/ Sample preparation)
02:30PM~04:00PM	Sample제작2(Back-side Thinning/ Thinning 실습)

Basic Course

- 교육대상: 미세조직 관찰법을 배우려는 초보자
- 교육참가비용: 5 만원/1 인
- 교육참가인원: 선착순 15 명
- 강사: 서임춘/김광섭 실습지원: 신은경

1. Microstructures Sample preparation for Electronic Materials

10:00AM~11:00AM	시편준비방법 및 관찰법
11:10AM~11:50AM	Sectioning 장비 작동법 및 실습
12:00AM~01:00PM	점심식사
01:15PM~02:15PM	Cold Mounting 실습
02:30PM~03:30PM	Polishing 실습 1
03:50PM~05:00PM	Polishing 실습 2

2. Microstructures Sample preparation for Metallurgy

10:00AM~11:00AM	시편준비방법 및 관찰법
11:10AM~11:50AM	Sectioning 장비 작동법 및 실습
12:00AM~01:00PM	점심식사
01:15PM~02:15PM	Hot Mounting/Cold Mounting 실습
02:30PM~03:30PM	Polishing 및 관찰 실습 1
03:50PM~04:40PM	Polishing 및 관찰 실습 2

Special Course

EBSD SAMPLE PREPARATION

오전: 이론/ 오후: 실습

그 외 Special Course는 별도 공지 예정

-이상-